

| | Type | Hits | Search Text | DBs | Time Stamp |
|----|------|------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|---------------------|
| 30 | BRS | 125 | (thin adj film adj (transistor transistors) TFT) and island same (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:16 |
| 31 | BRS | 1217 | (thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) with semiconductor with (insulate insulator insulating insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:15 |
| 32 | BRS | 9 | (thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) with semiconductor with (insulate insulator insulating insulation) and island with (sidewall spacer) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:12 |
| 33 | BRS | 93 | (thin adj film adj (transistor transistors) TFT) and island with (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:16 |
| 34 | BRS | 4 | ("6387737" "6459124").pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:07 |
| 35 | BRS | 537 | (thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) with semiconductor | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:56 |

| | Type | Hits | Search Text | DBs | Time Stamp |
|----|------|------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|---------------------|
| 36 | BRS | 35 | (thin adj film adj (transistor transistors) TFT) and heat\$treating near5 (insulating insulator insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:52 |
| 37 | BRS | 426 | (thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:16 |
| 38 | BRS | 7326 | (thin adj film adj (transistor transistors) TFT) and island | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:10 |
| 39 | BRS | 238 | (thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) with semiconductor and island | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:56 |
| 40 | BRS | 112 | (thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) near5 semiconductor and island | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:56 |
| 41 | BRS | 790 | (thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) and island | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:55 |

| | Type | Hits | Search Text | DBs | Time Stamp |
|----|------|------|---------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|---------------------|
| 42 | BRS | 2354 | (thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:55 |
| 43 | BRS | 14 | (thin adj film adj (transistor transistors) TFT) and heat\$treating with (insulating insulator insulation) with semiconductor and island | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:36 |
| 44 | BRS | 51 | (thin adj film adj (transistor transistors) TFT) and heat\$treating with (insulating insulator insulation) with semiconductor | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | 2006/09/01 14:36 |